

## APPLICATION DATA SHEET

## APPLICATION INFORMATION

Application Type:: REGULAR  
Subject Matter:: UTILITY  
CD-ROM or CD-R?:: NONE  
Title:: SEMICONDUCTOR DEVICE AND ITS  
MANUFACTURING METHOD  
Attorney Docket Number:: 263878US2PCT  
Total Drawing Sheets:: 12

## INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR  
Primary Citizenship Country:: Japan  
Status:: FULL CAPACITY  
Given Name:: Kenji  
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Country of Residence:: Japan  
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Country of Mailing Address:: Japan  
Postal or Zip Code of Mailing Address:: 305-8568

Applicant Authority Type:: INVENTOR  
Primary Citizenship Country:: Japan  
Status:: FULL CAPACITY  
Given Name:: Junji  
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Country of Mailing Address:: Japan  
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## CORRESPONDENCE INFORMATION

Correspondence Customer Number::

22850

## REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

## DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/JP03/08146	06/26/03

## FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2002-189161	Japan	06/28/02	YES

## ASSIGNMENT INFORMATION

Assignee Name:: National Institute of Advanced Indust Sci & Tech  
Street of Mailing Address:: 3-1, Kasumigaseki 1-chome, Chiyoda-ku  
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Country of Mailing Address:: Japan  
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